



AF/2815/B

PATENT  
Attorney Docket No. SEL 154

**THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: )  
 )  
Shunpei Yamazaki )  
 )  
Serial No: 09/479,262 )  
 )  
Filed: January 5, 2000 )  
 )  
Art Unit: 2815 )  
 )  
Examiner: Edward J. Wojciechowicz )  
 )  
For: SEMICONDUCTOR DEVICE AND )  
METHOD OF MANUFACTURING )  
THE SAME )

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:  
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Shannon Wallace  
Name of applicant, assignee, or Registered Rep.  
Shannon Wallace 4/12/04  
Signature Date

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT C (AFTER FINAL)**

Dear Sir:

In response to the Final Rejection dated February 12, 2004, please amend the above-identified application as follows: